

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Jung-wan KO et al.

CONFIRMATION NO.: 1606

APPLICATION NO.: 10/779,767

GROUP ART UNIT: 2627

FILING DATE: February 18, 2004

EXAMINER: Kim Kwok CHU

TITLE: Recording medium for storing write protection information and write protection method thereof

INFORMATION DISCLOSURE STATEMENT

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby submit the following information in accordance with the duty of disclosure set forth in 37 C.F.R. § 1.56. In accordance with 37 C.F.R. §§ 1.97 and 1.98, copies of the non-US patent documents being submitted are enclosed. For each foreign non-English document submitted, unless otherwise noted and/or provided, a corresponding English Abstract is provided. The documents are being presented after the mailing of a Final Office Action in accordance with 37 C.F.R. § 1.97(d)(1), and each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement, and the appropriate fee is included via EFS-Web.

To assist the Examiner, the documents are listed on the attached form PTO/SB/08. It is respectfully requested that an Examiner-initialed copy of this form be returned to the undersigned.

Respectfully submitted,

Dated: May 14, 2010

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